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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/593,557	11/17/2006	Yasuhiko Kasama	8075-1111	4919
466 YOUNG & TH	7590 04/10/200 OMPSON	EXAMINER		
209 Madison St	reet	ANGADI, MAKI A		
Suite 500 ALEXANDRIA, VA 22314			ART UNIT	PAPER NUMBER
			1792	
			MAIL DATE	DELIVERY MODE
			04/10/2009	PAPER

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

	Application No.	Applicant(s)				
	10/593,557	KASAMA ET AL.				
Office Action Summary	Examiner	Art Unit				
	MAKI A. ANGADI	1792				
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply						
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication. - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).						
Status						
<u> </u>	shruary 2009					
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·=	/					
, 	closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.					
Disposition of Claims						
4)⊠ Claim(s) <u>3-7 and 9-17</u> is/are pending in the application.						
4a) Of the above claim(s) is/are withdrawn from consideration.						
5) Claim(s) is/are allowed.						
6)⊠ Claim(s) <u>3-7 and 9-17</u> is/are rejected.						
7) Claim(s) is/are objected to.						
8) Claim(s) are subject to restriction and/or	election requirement					
	cicolion requirement.					
Application Papers						
9)☐ The specification is objected to by the Examine						
10)☐ The drawing(s) filed on is/are: a)☐ accepted or b)☐ objected to by the Examiner.						
Applicant may not request that any objection to the	drawing(s) be held in abeyance. See	e 37 CFR 1.85(a).				
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).						
11)☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.						
Priority under 35 U.S.C. § 119						
 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 						
Attachment(s)	/\ ☐ Intor-iou Comerce	(PTO 413)				
1) X Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948)	4) Interview Summary (PTO-413) Paper No(s)/Mail Date					
3) Information Disclosure Statement(s) (PTO/SB/08) 5) Notice of Informal Patent Application						
Paper No(s)/Mail Date 6) U Other:						

DETAILED ACTION

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

1. Claims 3-6, 9, 12 and 17 are rejected under 35 U.S.C. 103(a) over Miley et al. (US Patent No. 6,171,451).

As to claims 3 and 6, Miley discloses a fullerene production method (col.5, lines 6-11) that comprises: generating plasma (Fig.1, col.6, lines 59-60) containing target ions in spherical volume vessel (Fig.1A, col.6, lines 61-62); applying a control voltage (col.6, line 60) to an electric potential body/grid (col.6, line 61-64) in contact with plasma to control density of the target ions (col.7, lines

1-4); irradiating plasma towards deposition assistance substrate and fullerene is deposited at the bottom of the chamber (col.10, lines 15-18) (Fig.2); applying a bias voltage (col.13, lines 52-67, claim 18) of a polarity opposite to that of the target ions with acceleration energies (col.9, lines 65-67, col. 10, lines 1-10); applying bias voltage to provide containment ions and generate material molecules to internally contain target ions (col.14, lines 25-31). It is noted that the lower chamber region serves the role of substrate to collect fullerene.

Miley discloses the presence of ions in the fullerene production unit (col.7, lines 54-60, col.9, lines 65-67) but does not explicitly disclose collision ions. However, Miley's production apparatus discloses an electrical discharge in the hydrocarbon gas resulting in molecules and ionization of component atoms under grid voltage (col.9, line 57). Therefore, one would expect the generation of collision ions in the production apparatus in addition to target ions are generated in the presence of external voltage.

As to claims 4-5, Miley discloses a production apparatus for producing fullerene molecules (Fig.2) (col.5, lines 6-11) by generating plasma (col.6, lines 590-60) on deposition assistance substrate (lower chamber region) by plasma irradiation (col.6, lines 58-65).

As to claim 9, Miley discloses implantation target ions are cesium, argon, hydrogen, helium, nitrogen ions (col.14, lines 48-53).

As to claim 12, Miley discloses that the production method comprises fullerene (col.5, lines 31-35) and collision ions are fullerene positive or negative ions depending on target substance, propellant gas and applied voltage (Fig.11, col.47-65).

As to claim 17, Miley discloses ion density profiles in Fig.1C and 1D by measuring an electric current flowing between the substrate to measure the density of target ions (col.7, lines 43-61 and col.11, lines 36-57).

Claim Rejections - 35 USC § 103

2. Claims 7, 13-16 are rejected under 35 U.S.C. 103(a) over Miley et al. (US Patent No. 6,171,451) in view of Fetherston et al. (US Patent No. 5,693,376).

Miley discloses a production apparatus for producing fullerene (Fig.2) comprising a vacuum vessel (111); plasma generation means for generating plasma (col.9, lines 55-57) including generating target ions (col.9, lines 65-67); collision ions (col.11, lines 36-48); a substrate (in the lower chamber region, 125); bias power supply for applying bias voltage from 100V to about -1kV (col.14, lines 64-65) to measure density of target ions (col.13, lines 64-67 and col.14, lines 13-16); electric potential body (or wall structure) in a lattice pattern (Fig.9, lines 24-29); target molecules depositing on the substrate (Fig.6A, col.12, lines 4-23); fullerene ions that would include positive and negative ions because

of the electrical potential difference between the wall of the chamber 11 and the grid 112 (col.9, lines 65-67 and col.10 lines 1-10).

Miley is silent about the use of magnetic field generation means.

However, Fetherston discloses the use of magnetic bars (13) distributed about the outer periphery of the chamber wall (12) to generated magnetic field to influence ions generated by the plasma (col.5, lines 16-29, Fig.2).

Therefore, it would have been obvious to one of ordinary skill in the art at the time of the invention was made to employ magnetic field lines around the plasma chamber employed by Miely because Fetherston illustrates that the presence of magnetic field will enhance ionization of gas molecules in the production of materiel film (col.5 lines 28-39).

Claim Rejections - 35 USC § 103

3. Claims 10 is rejected under 35 U.S.C. 103(a) over Miley et al. (US Patent No. 6,171,451) as applied to claims 3 and 6, in further view of Takehara et al. (US pub. No. 2005/0129607).

Miley is silent about the use of target substance such as TTF, anthracene, pentacene etc. in the production of material film. However, Takehara discloses the use of anthracene, naphthalene and phenanthracene in the production of fullerene (paragraph 0022, 0045). Therefore, it would have been obvious to one of ordinary skill in the art at the time of the invention was made to select anthracene and other target material in the production of material film because Takehara discloses that the hydrocarbon fuel such as anthracene reacts with

oxygen to generate heat, thereby raising a gas temperature to a degree sufficient to produce material film such as fullerene (paragraph 0046).

Claim Rejections - 35 USC § 103

3. Claim 11 is rejected under 35 U.S.C. 103(a) over Miley et al. (US Patent No. 6,171,451) as applied to claim 3, in further view of Liu et al. Chemical Physics Letters, 331 (2000), pages 31-34.

Miley is silent about the size of the collision ions in the production of fullerene. However, Liu discloses the size of the collision carbon nanorods or fullerenes in the range 15-50 nm (page 32, paragraph 1) with a mean free path of 15 μm for carbon-carbon collision (page 33, paragraph 4). Therefore, it would have been obvious to one of ordinary skill in the art at the time of the invention was made to select the size of the collision ions and hence the size of nanotubes because Liu illustrates in Fig. 1 that the structural characteristics of the ionic collision of carbon ions during discharge process are responsible for building a longer nanotubes.

Response to Arguments

Applicant's arguments filed 2/23/2009 have been fully considered but they are not persuasive.

With respect to claims 3-16, applicants' arguments on pages 9-10 of the reply asserting that the reference of Miley does not disclose producing fullerenes are not convincing. Miley's reference discloses an apparatus and method for fullerene production by generating plasma (col.5, lines 6-10, col.10, and lines 10-

20, Fig.1A-1B). Applicants other arguments are based on amendments to a claims 3-7, 9-17. Office action on pages 2-5 above addresses these arguments. Objection to claim 11 has been withdrawn.

Conclusion

Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Anazawa et al. (US Patent No. 6,902,655) discloses a producing apparatus and production method for manufacturing carbon structure.

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Any inquiry concerning this communication or earlier communications from

the examiner should be directed to MAKI A. ANGADI whose telephone number is

(571)272-8213. The examiner can normally be reached on 8 AM to 4.30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the

examiner's supervisor, Nadine G. Norton can be reached on 571-272-1465. The

fax phone number for the organization where this application or proceeding is

assigned is 571-273-8300.

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/Maki A Angadi/

Examiner, Art Unit 1792

/Shamim Ahmed/

Primary Examiner, Art Unit 1792.